



IFW

Attorney Docket no: 0553-0200.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yamazaki et al.)
Serial No.: 10/664,615)
Filed: September 19, 2003)
For: Semiconductor Device And Manufacturing)
Method Thereof)
Examiner: Khiem D. Nguyen)
Art Unit: 2823)

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Name of applicant, assignee, or Registered Rep.

Shannon Wallace 11/16/04

Signature

Date

Commissioner for Patents
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AMENDMENT B

In response to the Office Action dated June 8, 2004, a three month extension of time being submitted herewith, please amend the above-identified application as follows: